Claims

| | [c1] | A device for producing a microfluid jet in a fluid environment, said device |
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| | | comprising: |
| | | a microfluid chamber having: |
| | | (i)at least one opening at a distal end; |
| | | (ii)a vapor producing means opposite said opening; |
| | | wherein said fluid chamber is capable of producing a microfluidic jet in a fluid |
| | | environment upon actuation. |
| | [c2] | The device according to Claim 1, wherein said vapor producing means produces |
| | | a vapor bubble inside said microfluid chamber. |
| The state of the s | [c3] | The device according to Claim 1, wherein said vapor producing means is a high |
| | | pressure vapor producing means. |
| | [c4] | The device according to Claim 3, wherein said high pressure vapor producing |
| | | means is an electrode. |
| | [c5] | The device according to Claim 3, wherein said high pressure vapor producing |
| | | means is a laser. |
| | [c6] | The device according to Claim 1, wherein said opening has a diameter ranging |
| | | from about 1 μ m to 1 mm. |
| | [c7] | The device according to Claim 1, wherein a distance of 1 μ m to 1 cm separates |
| | | said opening and said oppositely positioned vapor producing means. |
| | [c8] | |
| | | A device for producing a microfluidic jet in a fluid environment, said device |
| | | comprising: |
| | | a micronozzel having a distal end comprising a fluid chamber, wherein said |
| | | fluid chamber has a volume ranging from about 10 μ m 3 to 1 cm 3 and comprises: |
| | | (i)a single opening having a diameter ranging from about 1 μ m to 1 mm; and |
| | | (ii)a vapor producing means located opposite said opening and separated from |
| | | said opening by a distance ranging from about 1 μ m to 1 cm; |

wherein said fluid chamber is capable of producing a microfluidic jet in a fluid

[c9] The device according to Claim 8, wherein said vapor producing means is a high pressure vapor producing means capable of introducing energy into a fluid in a manner sufficient to produce a vapor bubble. [c10] The device according to Claim 9, wherein said high pressure vapor producing means comprises an electrode. [c11] The device according to Claim 9, wherein said vapor producing means comprises a laser. [c12] The device according to Claim 8, wherein said opening has a diameter ranging from about 1 µ m to 1 mm. [c13] A device for producing a microfluidic jet in a fluid environment, said device comprising: a micronozzel having a distal end comprising a fluid chamber, wherein said fluid chamber has a volume ranging from about 10 μ m³ to 1 cm³ and comprises: (i) a single opening having a diameter ranging from about 1 μ m to 1 mm; and (ii)an electrode vapor producing means located opposite said opening and separated from said opening by a distance ranging from about 10 µ m to 1 cm; wherein said fluid chamber is capable of producing a microfluidic jet in a fluid environment upon actuation. [c14] A device comprising at least two microfluid chambers, wherein each microfluid chamber comprises: (i)an opening at a distal end; and (ii)a vapor producing means opposite said opening; wherein each of said microfluid chambers is capable of producing a microfluidic jet in a fluid environment upon actuation. [c15] The device according to Claim 14, wherein said at least two microfluid chambers are individually actuatable.

The device according to Claim 14, wherein said device comprises a plurality of

environment upon actuation.

[c16]

said microfluid chambers.

[c17] The device according to Claim 16, wherein said device comprises an array of microfluid chambers.

[c18] A method of producing a fluid microjet in a fluid environment, said method comprising:

(a)contacting said fluid environment with a microfluid chamber comprising:

(i)an opening at a distal end; and

(ii)a vapor producing means opposite said openings;; and(b)actuating said vapor producing means in a manner sufficient to produce a vapor bubble inside said fluid chamber;

whereby a fluid microjet is produced in said fluid environment.

The method according to Claim 18, wherein said vapor producing means is actuated in a manner sufficient to produce pulsed microfluid jets in said fluid environment.

The method according to Claim 18, wherein said microfluid chamber is positioned proximal to a tissue in said fluid environment and said method is a method of physically modulating said tissue with said fluid microjet.

The method according to Claim 20, wherein said method is a method of cutting tissue.

The method according to Claim 20, wherein said micronozzel is positioned proximal to a cell and said method is a method of introducing fluid into said cell.

[c23] The method according to Claim 20, wherein said micronozzel is positioned proximal to a blood vessel and said method is a method of manipulating a clot by a water jet.

[c20]

[c21]

i.

[c22]